

Development of In-Situ Observation Holder and SEM stage

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Abstract

We are TEM holder・SEM stage Manufacturer In Japan

Topics

“Vacuum Transfer Standard ”

We are currently working on adding Vacuum Transfer functions to various in-situ holders and also believe that non-exposure will become the new common sense in advanced research projects.

We regard this stage as a stepping stone and will continue new challenges.



Pick Up products

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| ■Double Tilt Cryo Vacuum Transfer holder | : HR/EDS/EELS |
| ■Double Tilt MEMS Vacuum Transfer Holder | : Biasing /+1100 °C |
| ■Peltier SEM stage -80°C | : HR/EBSD / FIB |